## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: To Be Assigned

Examiner: To Be Assigned

In Re PATENT APPLICATION Of:

Applicants	:	Masaru TAKAISHI	)
Serial No.	:	To Be Assigned	) ) > INFORMATION
Filed	:	January 29, 2004	) INFORMATION ) DISCLOSURE ) STATEMENT
For	:	METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE	) STATEMENT )
Attorney Ref.	:	AI 322	) January 29, 2004

Commissioner for Patents P. O. Box 1450 Alexandria VA 22313-1450

Sir:

This is an information disclosure statement submitted in compliance with the timing requirements of 37 C.F.R. §1.97(b)(1).

Attached is a copy of one Japanese publication. The document is listed on the attached Form PTO-1449. Any relevance of this document can be gleaned from Figures 1 to 4.

Since this Information Disclosure Statement is being filed with the application, no certification or fee is required, and the requirements of 37 C.F.R. §§1.97 and 1.98 are deemed to be fully met as to the document submitted. Consideration of the submitted document is respectfully requested.

Respectfully submitted,

January 29, 2004

RHB:tz:

Date

Robert H. Berdo, Jr. (Reg. No. 38,075)

RABIN & BERDO, P.C. CUSTOMER NO. 23995

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FORM PTO-1449				Atty Docket	Applie	Application No.				
INFORMATION DISCLOSURE STATEMENT				AI 322	To Be	To Be Assigned				
				Applicant						
-				Masaru TAKAISHI						
				Filing Date	Grou	Group Unit				
				January 29, 2004	To Be	To Be Assigned				
U.S. PATENT DOCUMENTS										
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